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Nuclear Instruments and Methods in Physics Research B 188 (2002) ix-xi

NIM B
Beam Interactions with Materials & Atoms

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Contents

Editorial vii
Committees viii
Contents ix

I. Invited Papers

The architecture of cartilage: Elemental maps and scanning transmission ion microscopy/tomography
T. Reinert, U. Reibetanz, M. Schwertner, J. Vogt, T. Butz and A. Sakellariou 1
Prospects of ion projection techniques for maskless implantation at high ion energies
J. Meijer and A. Stephan 9
Quantitative, high sensitivity, high resolution, nuclear microprobe imaging of fluids, melts and minerals
C.G. Ryan, E. van Achterbergh, C.J. Yeats, S.L. Drieberg, G. Mark, B.M. McInnes, T.T. Win, G. Cripps and G.F. Suter 18
Ion beam synthesized nanoclusters for silicon-based light emission
L. Rebohle, J. von Borany, H. Fröb, T. Gebel, M. Helm and W. Skorupa 28
Ion beam analysis at cryogenic temperatures for polymer light emitting diodes
L.J. van IJzendoorn, M.P. de Jong, F.J.J. Janssen, G.G. Andersson, J.M. Sturm and M.J.A. de Voigt . . 36
Computational materials science of ion irradiation
K. Nordlund 41
The application of charged-particle microbeams in radiobiology
M. Folkard, B. Vojnovic, K.M. Prise and B.D. Michael 49

II. Ion Beam Analysis

Study of In diffusion into ZnSe buffer-layer material of chalcopyrite solar cells with rough surfaces by means of ERDA measurements
W. Bohne, S. Lindner and J. Röhrich 55
Exposure age dating by fluorine diffusion
C. Kottler, M. Döbeli, U. Krähenbühl and M. Nussbaumer 61
RBS and HIRBS studies of nanostructured $AgSiO_2$ sol–gel thin coatings
M. Kokkoris, C.C. Trapalis, S. Kossionides, R. Vlastou, B. Nsouli, R. Grötzschel, S. Spartalis, G. Kordas and Th. Paradellis 67
Ion beam studies of MBE grown GaN films on (1 1 1) silicon substrates
E. Alves, N.P. Barradas, T. Monteiro, R. Correia and U. Kreissig 73
Study of the irradiation damage in SiC by ion channeling
M. Kokkoris, S. Kossionides, A. Kyriakis, K. Zachariadou, G. Fanourakis, R. Vlastou and Th. Paradellis 78
Resonant Rutherford backscattering spectrometry and channeling studies on the effect of annealing of $La_{0.67}Ca_{0.33}MnO_3$ epilayers grown on $SrTiO_3(001)$ substrates using a facing-target sputtering technique
B. Sundaravel, I.H. Wilson, E.Z. Luo, J.B. Xu, H.W. Yeung, H. Li, C.F. Yeung, J.R. Sun and H.K. Wong 84

PII: S0168-583X(02) 00843-1

Study of roughness in $Ti_{0.4}Al_{0.6}N$/Mo multilayer structures
C.J. Tavares, L. Rebouta, E. Alves, N.P. Barradas, J. Pacaud and J.P. Rivière 90
Determination of nitrogen in metallic phases using the $^{14}N(d, p\gamma)^{15}N$ nuclear reaction
F.J. Ager, S. Elmrabet, A. Paúl, Á. Cea-Naharro, M.D. Ynsa, M.A. Respaldiza and J.A. Odriozola . . . 96
The state of the Guadiamar riverbed after the environmental disaster of 1998 analysed by TTPIXE
J.E. Martín, M.Á. Respaldiza and J. González-Labajo 102
New cross-sections and intercomparison of proton monitor reactions on Ti, Ni and Cu
S. Takács, F. Tárkányi, M. Sonck and A. Hermanne 106
Characterisation of hydrogen and erbium in carbon layers fabricated by PACVD for optical applications
A. Macková, V. Peřina, V. Hnatowicz, P. Nekvindová, V. Prajzler, I. Hüttel and J. Špirková 112
Determination of the charged particle beam energy/intensity uncertainties at multi-target irradiations
F. Ditrói 115
RBS, SY-XRF, INAA and ICP-IDMS of antimony implanted in silicon – A multi-method approach to characterize and certify a reference material
K.H. Ecker, U. Wätjen, A. Berger, L. Persson, W. Pritzkow, M. Radtke and H. Riesemeier 120

III. Microbeam Analysis, External Beam Analysis

Depth profiling of diffusion into cylindrical matrices using a scanning micro-beam
R.W. Smith and A.S. Clough 126
Characterisation of SiC by IBIC and other IBA techniques
M. Jakšić, Ž. Bošnjak, D. Gracin, Z. Medunić, Ž. Pastuović, E. Vittone and F. Nava 130
Ion beam analysis with external beams: Recent set-up improvements
T. Calligaro, J.-C. Dran, B. Moignard, L. Pichon, J. Salomon and Ph. Walter 135
A microbeam RBS analysis of low temperature direct-write inkjet deposited copper
C. Jeynes, G.G. Rozenberg, S.P. Speakman and J.H.G. Steinke 141
A photomultiplier-based secondary electron imaging system for a nuclear microprobe
L.C. Alves, M.B.H. Breese, M.F. da Silva and J.C. Soares 146
Investigation of beam-induced damage to ancient ceramics in external-PIXE measurements
M. Chiari, A. Migliori and P.A. Mandò 151
In situ dynamic analysis of solids or aqueous solutions undergoing chemical reactions by RBS or PIXE with external beams
A. Bouquillon, J.-C. Dran, G. Lagarde, P. Martinetto, F. Mathis, B. Moignard, J. Salomon and Ph. Walter 156
Measurement of low currents in an external beam set-up
M. Chiari, A. Migliori and P.A. Mandò 162

IV. Ion Beam Synthesis, Deposition, Implantation, Irradiation

Synthesis of amorphous $FeSi_2$ by ion beam mixing
M. Milosavljevic, G. Shao, N. Bibic, C.N. McKinty, C. Jeynes and K.P. Homewood 166
Carrier transport properties of ion beam synthesised $Si_{1-x}Ge_x$ alloy heavily doped with arsenic
C. Cerrina, A. Nejim, Y. Wang and P.L.F. Hemment 170
Ion beam synthesis of buried $CoSi_2$-structures
T. Vogel, J. Meijer, A. Stephan, U. Weidenmüller, Ü. Dagkaldiran, S. Kubsky, P. Baving, H.W. Becker and H. Röcken 174
The properties of β-$FeSi_2$ fabricated by ion beam assisted deposition as a function of annealing conditions for use in solar cell applications
C.N. McKinty, K.J. Kirkby, K.P. Homewood, S.P. Edwards, G. Shao, R. Valizadeh and J.S. Colligon . 179
Irradiation damage technology for manufacturable Josephson junctions
D.-J. Kang, N.H. Peng, R. Webb, C. Jeynes, G. Burnell, J.H. Yun, S.H. Moon, B. Oh, E.J. Tarte, D.F. Moore, M. Kelly and M.G. Blamire 183

Monte Carlo simulations of energetic proton beam irradiation damage defect productions in YBCO thin films with Au masks
N. Peng, C. Jeynes, R. Webb, I. Chakarov, D.J. Kang, D. Moore and M. Blamire 189
Implant isolation in GaAs device technology: Effect of substrate temperature
S. Ahmed, R. Gwilliam and B.J. Sealy 196
Microchemical and microstructural changes of Co cemented WC induced by ion implantation
W.L. Lin, J.M. Sang, X.J. Ding, J. Xu and X.M. Yuan 201
Electrical isolation of n-type InP layers by helium implantation at variable substrate temperatures
P. Too, S. Ahmed, R. Gwilliam and B.J. Sealy 205
Mathematical modelling of the response of tumour cells to radiotherapy
N.F. Kirkby, N.G. Burnet and D.B.F. Faraday 210

V. Accelerator Technology, Focusing Devices, Ion sources

Carbon beam acceleration using a simple injection method into an RFQ
M. Okamura, T. Katayama, R.A. Jameson, T. Takeuchi, T. Hattori and N. Hayashizaki 216
A study of a test APF-IH type linac as an injector for cancer therapy
T. Hattori, K. Yamamoto, N. Hayashizaki, H. Kashiwagi, Y. Takahashi, T. Hata, S. Okada, T. Sugita, M. Aoki, M. Okamura, S. Yamada, E. Osvath, D. Dudu and I. Vata 221
Study of a four hole ECR ion source for a HIF injector
H. Kashiwagi, T. Hattori, N. Hayashizaki, M. Okamura, Y. Takahashi, T. Hata, K. Ymamoto, S. Okada and T. Sugita 225
Acceleration test of APF-IH type implanter
K. Yamamoto, T. Hattori, S. Matsui, T. Hata, N. Hayashizaki, H. Kashiwagi and Y. Takahashi 229
A direct plasma injection system into an RFQ for clean and safe ion implantation
T. Takeuchi, T. Katayama, M. Okamura, K. Yano, A. Sakumi, T. Hattori, N. Hayashizaki and R.A. Jameson 233
Design of heavy-ion APF-IH type linac for atomic physics and medical use
T. Hata, T. Hattori, H. Kashiwagi, Y. Takahashi, K. Yamamoto, S. Matsui, D. Dudu, E. Osvath, I. Vata and S. Yamada 238
Beam acceleration test of the Ridgetron electron accelerator
N. Hayashizaki, T. Hattori, M. Odera, K. Nakayama, K. Isokawa, K. Sato and T. Fujisawa 243
Development of a continuously variable energy radio frequency quadrupole accelerator for SiC power semiconductor device fabrication
K. Amemiya, J. Ito, T. Ohno, T. Yasuda, T. Ohyanagi and A. Watanabe 247
Numerical study of the two-stage amplitude-controlled RF linear accelerator in the SWIFT ion implanter beamline
C. Christou and J. Gordon 251
The pulsed beam facility at the 3 MV Van de Graaff accelerator in Florence: Overview and examples of applications
N. Taccetti, L. Giuntini, G. Casini, A.A. Stefanini, M. Chiari, M.E. Fedi and P.A. Mandò 255
The use of solenoid lenses in a two-stage nuclear microprobe probe-forming system
M.B.H. Breese, D.N. Jamieson and B.L. Doyle 261
Preliminary experimental results on an excimer laser ion source
V. Nassisi, A. Pedone and A. Rainò 267
Electron beam propagation in a space-charge regime
L. Martina, V. Nassisi, G. Raganato and A. Pedone 272
Pulsing system of C_{60} beam for the TOF method
Y. Takahashi, T. Hattori, H. Kashiwagi, T. Hata, N. Hayashizaki, I. Sugai and K. Noda 278
Heavy ion AMS with a "small" accelerator
P. Steier, R. Golser, W. Kutschera, V. Liechtenstein, A. Priller, A. Valenta and C. Vockenhuber 283

Author index 288